

Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/608,914	AGRAWAL, AVNEESH
	Examiner	Art Unit
	Emmanuel Bayard	2611

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
375	130	8/30/06	zts
	132	8/30/06	cra